

**EAST Search History**

<b>Ref #</b>	<b>Hits</b>	<b>Search Query</b>	<b>DBs</b>	<b>Default Operator</b>	<b>Plurals</b>	<b>Time Stamp</b>
L1	2852	(257/66 OR 257/213). CCLS.	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	AND	ON	2008/08/28 18:11
L7	34	((metal adj oxide) silicon substrate gate electrode dielectric constant nitrogen oxygen).clm.	US-PGPUB; USPAT; USOCR	AND	ON	2008/08/28 18:12
L8	0	1 7	US-PGPUB; USPAT; USOCR	AND	ON	2008/08/28 18:13

**8/28/2008 6:13:52 PM****C:\Documents and Settings\jvalentine\My Documents\EAST\Workspaces\10-558271.wsp**